

Electronic Patent Application Fee Transmittal

Application Number:	10593830			
Filing Date:	22-Sep-2006			
Title of Invention:	PROBE APPARATUS, WAFER INSPECTING APPARATUS PROVIDED WITH THE PROBE APPARATUS AND WAFER INSPECTING METHOD			
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Attorney Docket Number:	296431US2PCT			
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U.S. National Stage under 35 USC 371 Filing Fees				
Description	Fee Code	Quantity	Amount	Sub-Total in USD(\$)
Basic Filing:				
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Claims:				
Miscellaneous-Filing:				
Petition:				
Patent-Appeals-and-Interference:				
Post-Allowance-and-Post-Issuance:				
Utility Appl issue fee	1501	1	1440	1440
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Description	Fee Code	Quantity	Amount	Sub-Total in USD(\$)
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Total in USD (\$)				1740